

Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 124102		APPLICATION NO. New U.S. National Stage of PCT/FR03/003789	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANTS Philippe ROBERT et al.			
				FILING DATE May 27, 2005			
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	
/RC/	1	US 2002/0047172 A1	04/25/2002	Reid			
/RC/	2	5,582,678	12/10/1996	Komuro			
/RC/	3	5,430,421	07/04/1995	Bornand et al.			
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	
/RC/	4	WO 02/068321 A2	09/06/2002	WIPO			
/RC/	5	WO 00/33089 A2	06/08/2000	WIPO			
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
/RC/	6	Song et al.; "Wafer Level Vacuum Packaged De-Coupled Vertical Gyroscope By a New Fabrication Process";					
		Proceedings of the IEEE 13 th Annual International Conference on Micro Electro Mechanical Systems; pp. 520-524;					
		XP010377181; January 23, 2000					
EXAMINER				DATE CONSIDERED			
/Roberts Culbert/				06/04/2007			
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

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